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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date 4 29 2004  
Mo. Day Yr.  
Atty. Docket 00862-022172  
Application 09/819,669

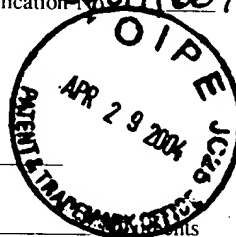
Sir:

Kindly acknowledge receipt of the accompanying:

- ☐ Response to Official Action. \_\_\_\_\_
- ☐ Check for \$ \_\_\_\_\_ (claims fee)
- ☐ Petition under 37 CFR 1.136 and Check for \$ \_\_\_\_\_
- ☐ Notice of Appeal and Check for \$ \_\_\_\_\_
- ☒ Information Disclosure Statement, PTO-1449 and SIX (6)
- ☐ Claim for priority and certified copies of \_\_\_\_\_ priority applications
- ☐ Issue fee transmittal and Check for \$ \_\_\_\_\_
- ☐ Other (specify) \_\_\_\_\_

by placing your receiving date stamp hereon and returning to deliverer.

Atty. SAU/EDB Due Date \_\_\_\_\_  
Mo. Day Yr.



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B  
Sfw

00862.022172

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yasuhiro SHIMADA et al.

Application No.: 09/819,669 ✓

Filed: March 29, 2001

For: ELECTRON OPTICAL SYSTEM ARRAY,  
METHOD OF FABRICATING THE SAME,  
CHARGED PARTICLE BEAM EXPOSURE  
APPARATUS, AND DEVICE  
MANUFACTURING METHOD

Examiner: K. Nguyen

Group Art Unit: 2881

Confirmation No.: 3218

Allowed: May 6, 2004

May 25, 2004

**Mail Stop Issue Fee**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

LETTER REQUESTING CONSIDERATION  
OF PAPERS TIMELY FILED

Sir:


Applicants have received a Notice of Allowance and a Notice of Allowability dated May 6, 2004, in the above-identified application. Applicants filed a Fifth Supplemental Information Disclosure Statement on April 29, 2004, prior to issuance of the Notice of Allowance and Notice of Allowability on May 6, 2004. To date, the Examiner has not indicated his consideration of those papers. Accordingly, Applicants request that the Examiner consider the material submitted in the Fifth Supplemental Information Disclosure Statement, by returning a copy of the initialed PTO-1449 form attached to that Information Disclosure Statement. Attached, for the Examiner's convenience, are copies

of the Fifth Supplemental Information Disclosure Statement, the PTO-1449 form, and the U.S. Patent and Trademark Office date stamped postcard receipt indicating the filing of those papers on that date.

Applicants believe that no fees should be incurred in connection with filing this paper. However, the Commissioner is authorized to charge Deposit Account No. 06-1205, should any fees be associated herewith. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicants  
Steven E. Warner  
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

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00862.022172

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: K. Nguyen
Yasuhiro SHIMADA et al.	)	
	:	Group Art Unit: 2881
Application No.: 09/819,669	)	
	:	Confirmation No.: 3218
Filed: March 29, 2001	)	
	:	
For: ELECTRON OPTICAL SYSTEM ARRAY,	)	
METHOD OF FABRICATING THE SAME,	:	April 29, 2004
CHARGED PARTICLE BEAM EXPOSURE	)	
APPARATUS, AND DEVICE	:	
MANUFACTURING METHOD	)	

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

FIFTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statements filed on October 23, 2001, January 29, 2003, June 5, 2003, August 7, 2003, and January 28, 2004, and in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form and to the copending application discussed below. Copies of the listed documents are also enclosed.

These documents were cited during prosecution of copending U.S. patent application number 09/819,907, filed March 29, 2001, a copy of which was previously submitted in this application.


Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

Applicants also would like to clarify the record. Specifically, Applicants filed a Letter Submitting Corrected PTO-1449 Form on March 4, 2004. The information given in that Letter is correct. Namely, on the second page of the List of References Cited by Applicants (PTO-1449 form attached to the Fourth Supplemental Information Disclosure Statement filed on January 28, 2004), the third-listed U.S. patent number should be -- 6,566,664 --, rather than "6,566,644." Applicants, however, carried the mistake over into the corrected PTO-1449 form attached to the above-noted Letter. In any event, the correct patent number, namely -- 6,566,664 -- was previously cited in the Third Supplemental Information Disclosure Statement filed on August 7, 2003. Accordingly, the "corrected" PTO-1449 form provided with the above-noted Letter should be ignored.

No fee is believed to be due with the filing of this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed necessary for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicants  
Steven E. Warner  
Registration No. 33,326

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New York, New York 10112-3801  
Facsimile: (212) 218-2200

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FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

LIST OF REFERENCES CITED BY APPLICANT(S)  
(Use several sheets if necessary)

April 29, 2004

ATTY DOCKET NO. 00862.022172

APPLICATION NO. 09/819,669

APPLICANT Yasuhiro SHIMADA et al.

FILING DATE March 29, 2001

GROUP 2881

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	US-6,465,796 B1	10/15/2002	Haraguchi et al.	250	492.23	
	US-4,200,794	04/29/1980	Newberry et al.	250	396 ML	
	US-6,121,625	09/19/2000	Ito et al.	250	492.22	
	US-6,014,200	01/11/2000	Sogard et al.	355	53	
	US-5,731,591	03/24/1998	Yamada et al.	250	492.2	
	US-5,105,089	04/14/1992	Yamada	250	492.2	

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1